

UNITED STATES DEPARTMENT OF COMMERCE United States Patent and Trademark Office Address: COMMISSIONER FOR PATENTS P.O. Box 1450 Alexandria, Virginia 22313-1450 www.uspto.gov

BIB DATA SHEET

CONFIRMATION NO. 5477

SERIAL NUM	IBER	FILING or		371(c) CLASS			GROUP ART UNIT			ATTORNEY DOCKET NO.	
10/519,15	10/519,152 08/10/2		_		438		2811		23165		
		RULI	=								
APPLICANTS Masatomo Shibata, Tokyo, JAPAN; Yuichi Oshima, Tokyo, JAPAN; Takeshi Eri, Tokyo, JAPAN; Akira Usui, Tokyo, JAPAN; Haruo Sunagawa, Tokyo, JAPAN; ** CONTINUING DATA **********************************											
JAPAN 2002-190270 06/28/2002 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **											
Foreign Priority claimed Yes No		☐ Met af	ter	STATE OR COUNTRY			TOT/				
Verified and /TRAN Q TRAN/ Acknowledged Examiner's Signature			TT Initials	ince	JAPAN		4	17		6	
ADDRESS											
SCULLY SCOTT MURPHY & PRESSER, PC 400 GARDEN CITY PLAZA SUITE 300 GARDEN CITY, NY 11530 UNITED STATES											
TITLE											
Porous substrate and its manufacturing method, and gan semiconductor multilayer substrate and its manufacturing method											
							☐ All Fees				
						1.16 Fees (Filing)					
FILING FEE RECEIVED	FEES: Authority has been given in Paper No to charge/credit DEPOSIT ACCOUNT No for following:						☐ 1.17 Fees (Processing Ext. of time)				
1630							1.18 Fees (Issue)				
							Other				
						☐ Credit					